Docket No.: 49657-871

PATENT

elletias manisla 6/12/03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e Application of

Masahiko TAKEUCHI, et al.

Serial No.: 09/725,853

Filed: November 30, 2000

For:

JUN 1 0 2003

PHOTOMASK INCLUDING AUXILIARY MARK AREA, SEMICONDUCTOR DEVICE AND

Group Art Unit: 2823

Examiner: J.A. Garcia

MANUFACTURING METHOD THEREOF

RESPONSE TO RESTRICTION REQUIREMENT

Mail Stop Restriction Requirement Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

top Restriction Requirement hissioner for Patents fox 1450 adria, VA 22313-1450

Noting the Office Action of May 21, 2003 wherein restriction has been required, Applicant(s) hereby elect Group I (claims 1-13) for prosecution in the above-identified application.

To the extent necessary, a petition for an extension of time under 37 C.F.R. 1.136 is hereby made. Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY

Gene Z. Rubinson

Registration No. 33,351

Gene 3. Rutin

600 13th Street, N.W. Washington, DC 20005-3096 (202) 756-8000 GZR:lnm Facsimile: (202) 756-8087

WDC99 769155-1.049657.0871

Date: June 10, 2003